

**Notice of References Cited**

Application/Control No.

09/819,799

Applicant(s)/Patent Under  
Reexamination  
HECKMEIER ET AL.

Examiner

Shean C Wu

Art Unit

1756

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6190576 B1	02-2001	Andou et al.	252/299.63
	C	US-6331064 B1	12-2001	Nishiyama et al.	362/260
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	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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